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Docket No.: 2328-050

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Jian J. CHEN et al.

U.S. Patent Application No. 09/821,027

Filed: March 30, 2001

: : EXPEDITED PROCEDURE
: : Response under 37 CFR 1.116
: Confirmation No.
5541
:
: Group Art Unit: 1763
:
: Examiner: ANNA M. CROWELL

For: INDUCTIVE PLASMA PROCESSOR HAVING COIL WITH PLURAL WINDINGS
AND METHOD OF CONTROLLING PLASMA DENSITY

AMENDMENT

MailStop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION
I HEREBY CERTIFY THAT THIS PAPER IS BEING FACSIMI-
LE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE

ON THE DATE SHOWN BELOW

Donna L. Lizaola
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SIGNATURE

DATE

571-273-8300

FACSIMILE NUMBER

This paper is submitted in reply to the communication for the Board of Patent Appeals and Interference (Paper No. 0106), mailed January 31, 2006. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.